

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2/a
J. Scott
6/2/01

In re Patent Application of

Tsukasa Yajima

Attn: Applications Branch

Divisional to Serial No. 09/038,749

Attorney Docket No. PNET.009D

Filed: January 25, 2001

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE (To be Amended)

PRELIMINARY AMENDMENT

Honorable Assistant Commissioner
of Patents and Trademarks,
Washington, D.C. 20231

Date: January 25, 2001

Sir:

Preliminary to the examination of the above-identified application, please enter the following amendments and remarks.

In the Abstract:

Please cancel the Abstract and replace with the Abstract attached herewith.

In the Title:

Please amend the title to read --SEMICONDUCTOR DEVICE HAVING
PROTECTIVE LAYER ON FIELD OXIDE--.